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( Not for submission under 37 CFR 1.99)

Application Number	10786795
Filing Date	2004-02-24
First Named Inventor	VIERI VANGHI
Art Unit	3351
Examiner Name	HEIBER, SHANTELL LAKETA
Attorney Docket Number	040003

**U.S. PATENTS**

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/S.H./	1	1304269	CN		2001-07-18	SAMSUNG ELECTRONICS CO., LTD.		<input type="checkbox"/>

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Examiner Signature	/Shantell Heiber/	Date Considered	03/19/2009
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